

AMENDMENTS TO THE SPECIFICATION:

Please amend the title of the application as follows:

METHOD OF FABRICATING RADIO FREQUENCY MICROELECTROMECHANICAL
SYSTEMS (MEMS) DEVICES ON LOW-TEMPERATURE CO-FIRED CERAMIC (LTCC)
SUBSTRATES

Please amend the Specification to add at the beginning of the specification on page 1 the following paragraph:

This application is a divisional of Application Serial No. 10/147,907, filed May 20, 2002, and claims the benefit of Provisional Application No. 60/291,647, filed May 18, 2001, the entire contents of which are hereby incorporated by reference in this application.